

**A SYSTEM FOR THE IMPROVED HANDLING OF WAFERS
WITHIN A PROCESS TOOL**

Aggarwal et al.

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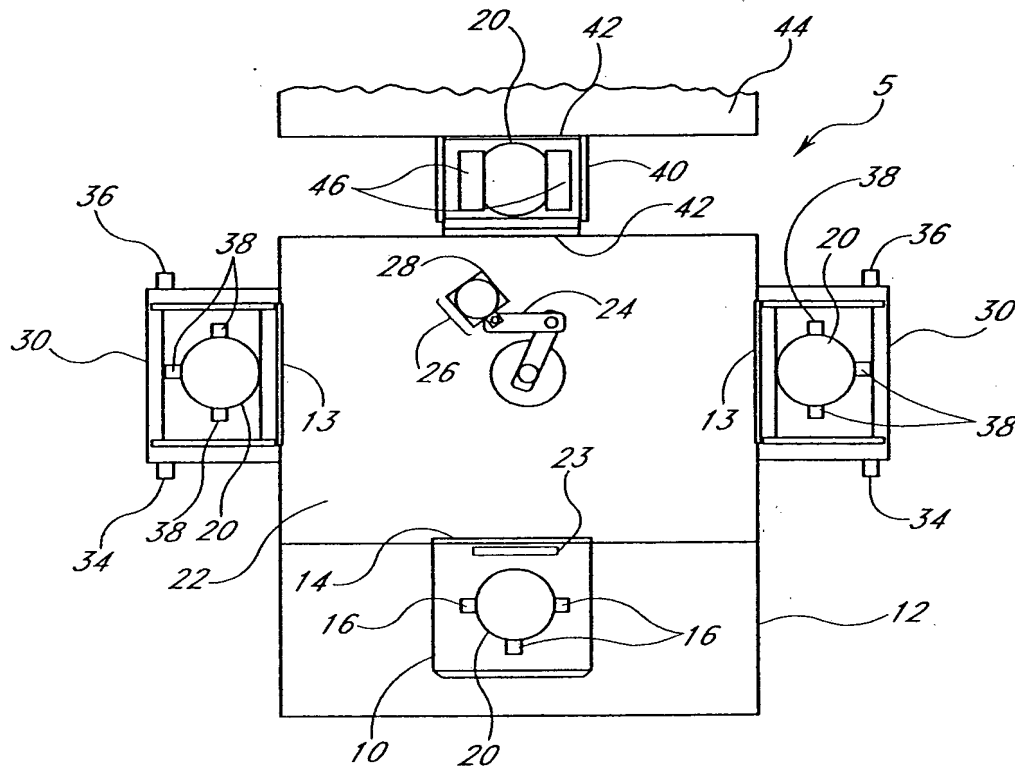


FIG. 1

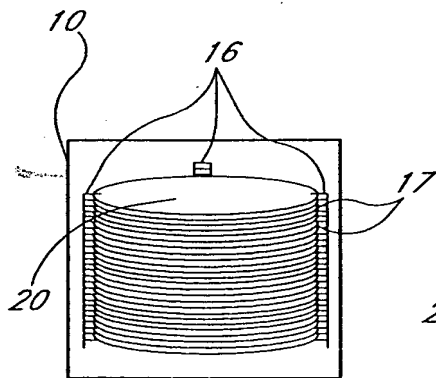


FIG. 2A

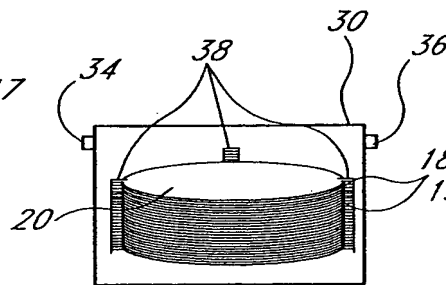


FIG. 2B

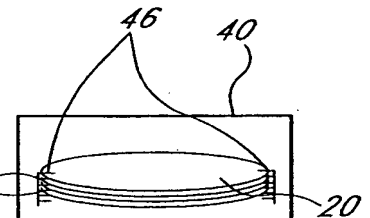


FIG. 2C

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FIG. 3A

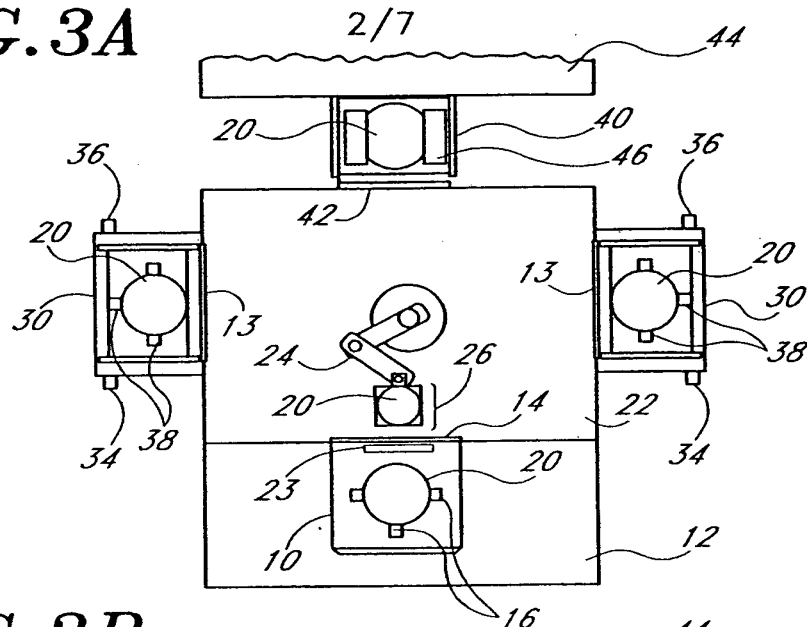


FIG. 3B

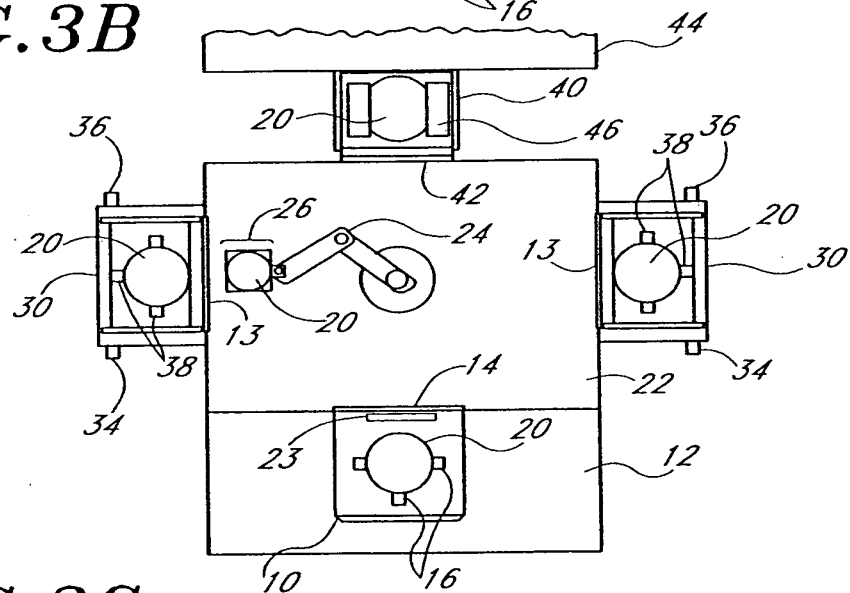
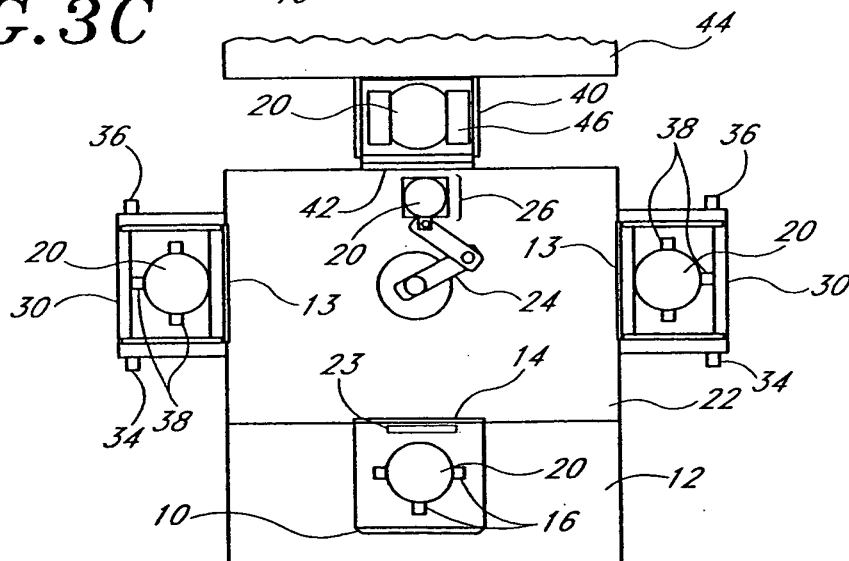


FIG. 3C



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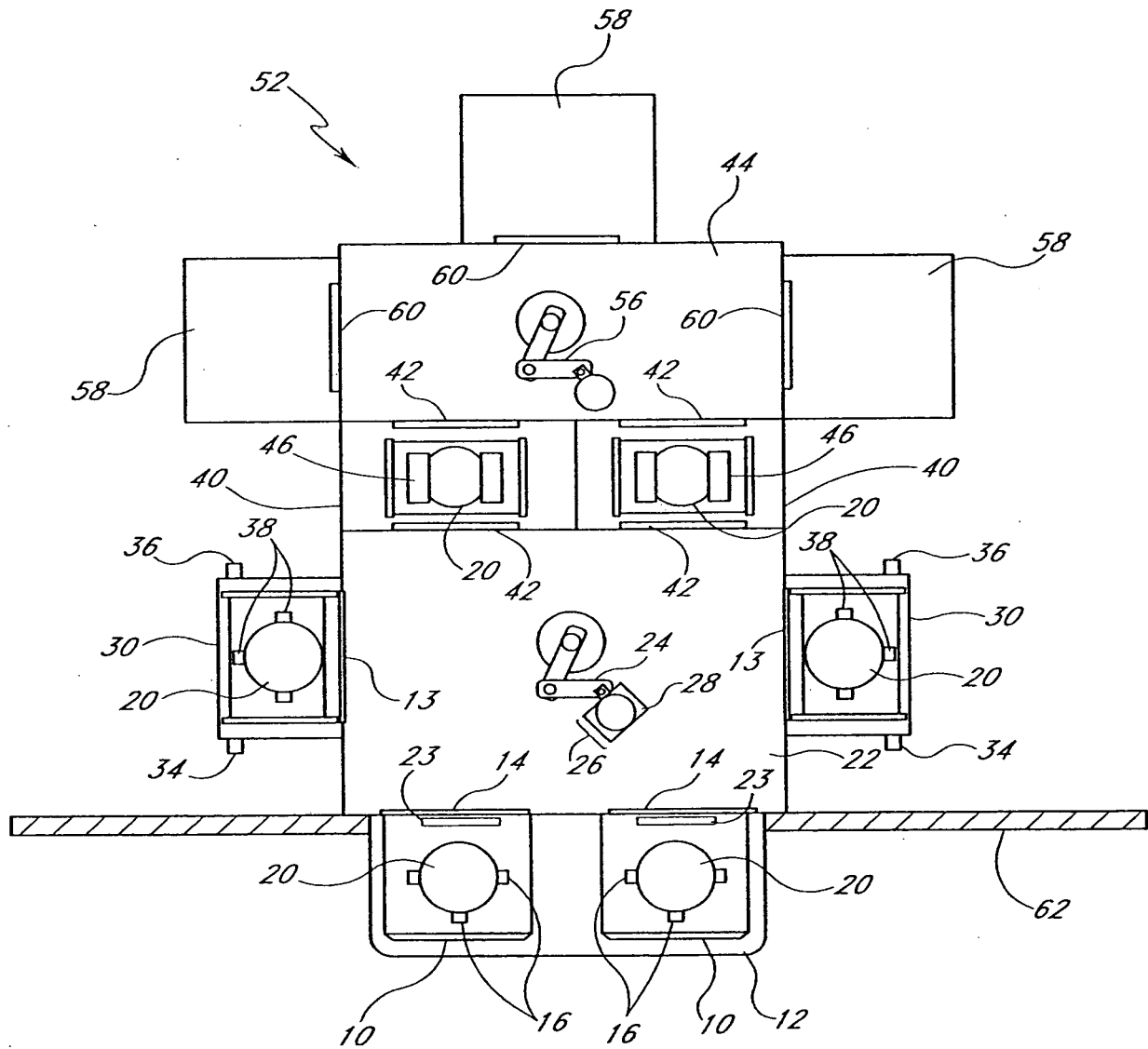


FIG. 4

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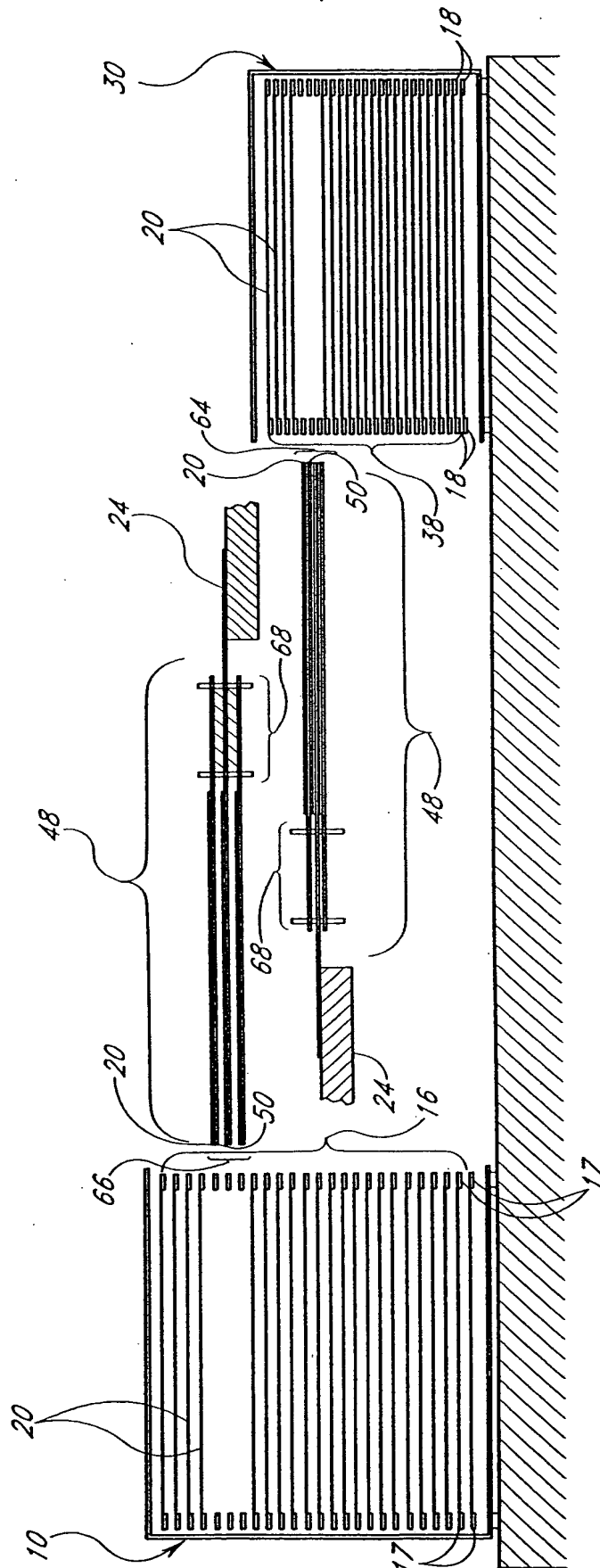


FIG. 5

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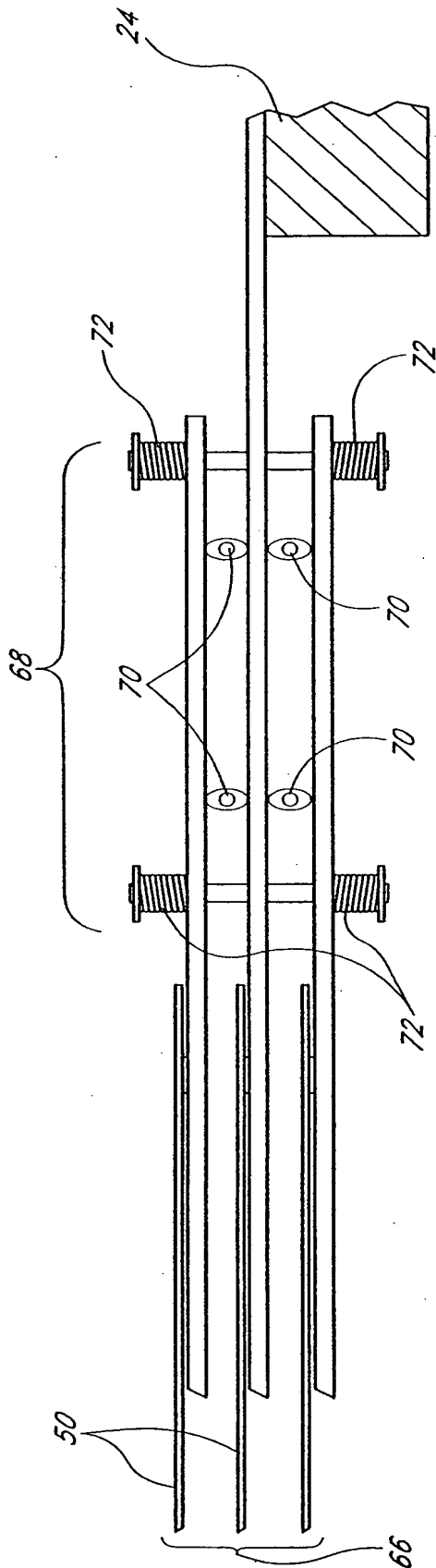


FIG. 6A

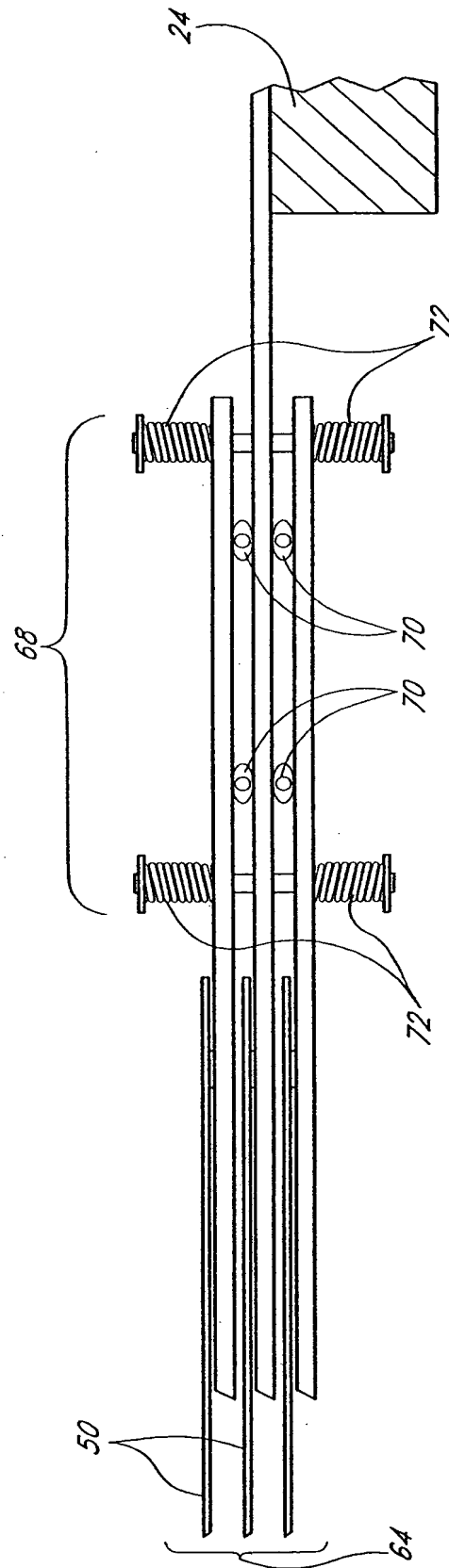


FIG. 6B

A SYSTEM FOR THE IMPROVED HANDLING OF WAFERS
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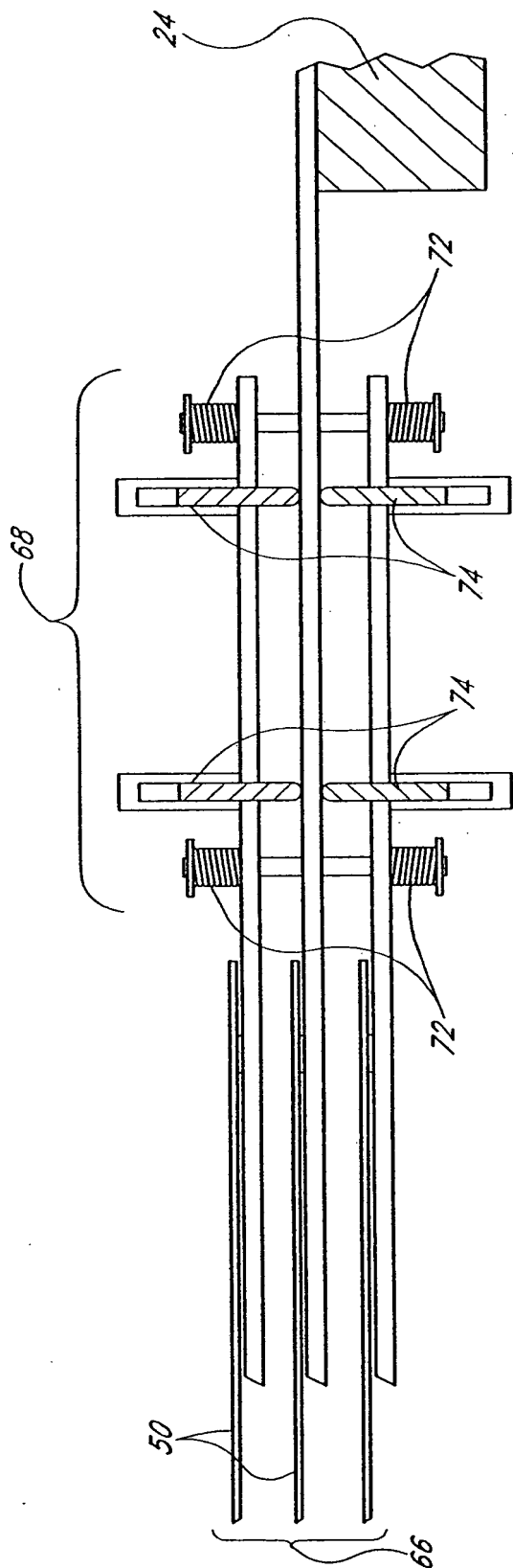


FIG. 7A

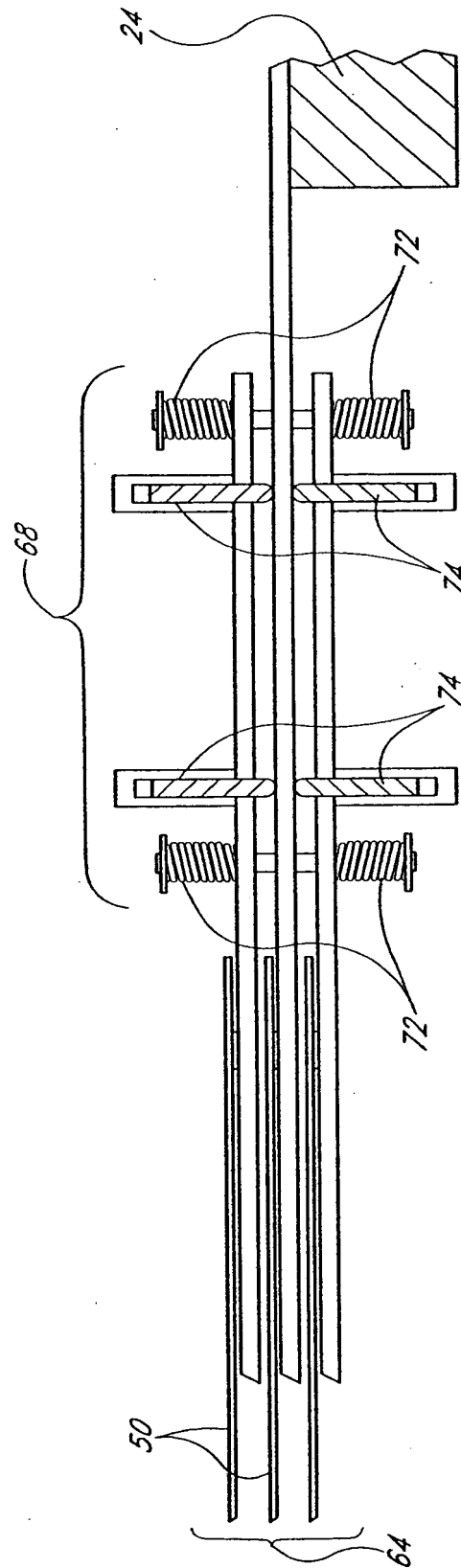


FIG. 7B

*A SYSTEM FOR THE IMPROVED HANDLING OF WAFERS
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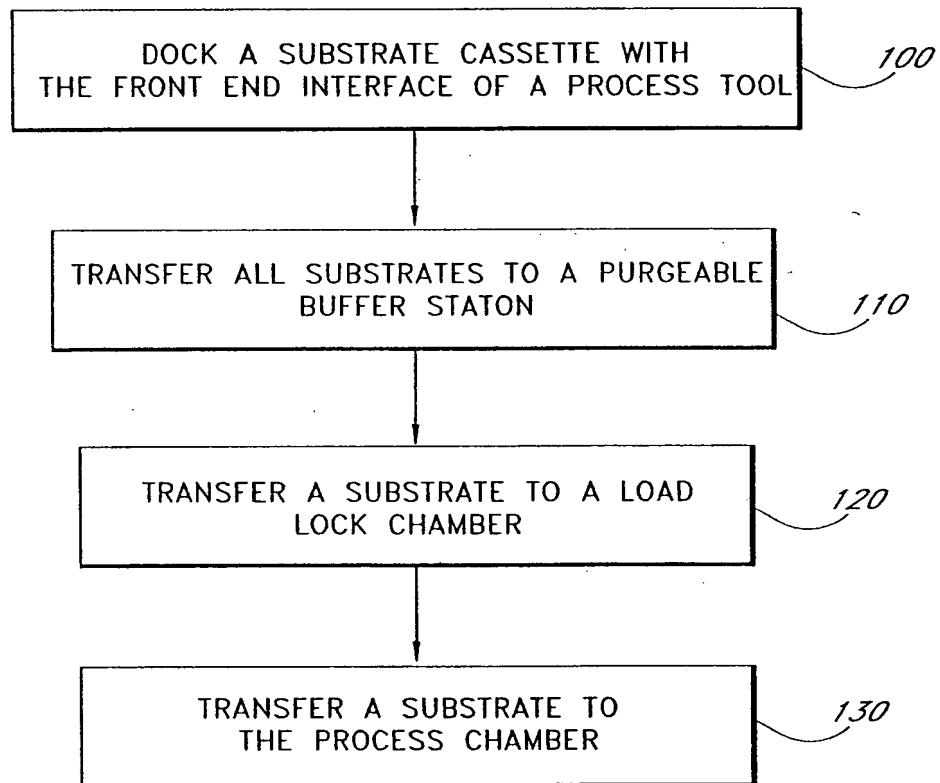


FIG. 8